	Application Number		10596390	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Filing Date		2006-06-12	
	First Named Inventor YI, Se		Seuyng-Hwan et al.	
	Art Unit	L		
	Examiner Name			
	Attorney Docket Numb	er	P07596US00	

			Remove			
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear
/MT/	1	4189236		1980-02-19	Hogg et al.	
/MT/	2	5009493		1991-04-23	Koch et al.	
/MT/	3	5116120		1992-05-26	Picker	
/MT/	4	5170064		1992-12-08	Howe	
/MT/	5	5341214		1994-08-23	Wong	
/MT/	6	5444249		1995-08-22	Wong	
/MT/	.7	5488227		1996-01-30	Sweet	
/MT/	8	5973326		1999-10-26	Parry et al.	

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Not for submission under 37 CFR 1.99)

Application Number		10596390	
Filing Date		2006-06-12	
First Named Inventor	YI, S	euyng-Hwan et al.	
Art Unit			
Examiner Name			
Attorney Docket Number		P07596US00	

						_		_			
/MT/	9	6067840		2000-05-30		Chelvayohan o					
/MT/	10	6194735	B1	2001-02-27		Martin					
If you wis	n to ac	ld additional U.S. Pater	nt citatio	n inform	ation pl	ease click the	Add button.		Add		
			U.S.P	ATENT	APPLIC	CATION PUBI	LICATIONS	,	Remove		
Examiner Initial*	Cite No	Publication Number	Kind Code ¹	Publica Date	ition	Name of Pate of cited Docu	entee or Applicant ment	Releva		Lines where	
_	1					-					
If you wis	h to a	dd additional U.S. Publi	shed Ap	plication	citatio	n information p	olease click the Add	buttor	1. Add		
				FOREIG	3N PAT	ENT DOCUM	ENTS		Remove		
Examiner Initial*	Cite No	Foreign Document Number ³	Country Code ²	•	Kind Code ⁴	Publication Date	Name of Patentee Applicant of cited Document	e or	where Rel	or Relevant	T5
/MT/	1	WO 98/09152	WO		A1	1998-03-05	Martin, Hans et al.				
/MT/	2 ·	WO 99/41592	wo		A1	1999-08-19	Martin, Hans et al.				
If you wis	h to a	dd additional Foreign Pa	atent Do	cument	citation	information p	lease click the Add	button	Add		•
NON-PATENT LITERATURE DOCUMENTS Remove											
Examiner Initials* Cite No Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.									T 5		
/MT/	1	Park, I. Y, et al. "An implementation of DIR type CO2 gas sample chamber and measuring hardware for capnograph system in consideration of the time response characteristics" Journal of Korean Sensor Society, vol. 5, no. 5, pp. 279-285, 2001									

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)

Application Number		10596390				
Filing Date		2006-06-12				
First Named Inventor	YI, S	euyng-Hwan et al.				
Art Unit						
Examiner Name				•		
Attorney Docket Number		P07596US00				

/MT/	/MT/ Noro, Makoto et al., "CO2/H20 Gas Sensor Using A Tunable Fabry-Perot Filter with Wide Wavelength Range" IEEE Conference on MEMS, pp. 319-322, 2003; 0-7803-7744-3									
/MT/	3	-	Kaneyasu, K., et al. "A carbon dioxide gs sensor based on solid electrolyte for air quality control" 2000 Elsevier Sensors and Actuators B 66, pp 56-58							
If you wis	sh to a	dd addi	tional non-patent literature document c	itation information p	olease click the Add b	outton Add	L			
	,		EXAMIN	ER SIGNATURE						
Examiner Signature /Marcus Taningco/ Date Considered 01/02/2008						01/02/2008				
			eference considered, whether or not ci mance and not considered. Include co							
Standard S 4 Kind of do	ST.3). ³ l ocument	For Japai by the a	Patent Documents at www.USPTO.GOV or MFnese patent documents, the indication of the yeappropriate symbols as indicated on the document is attached.	ar of the reign of the Emp	peror must precede the ser	ial number of the patent doc	ument.			